



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 8, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG754574890

LABORATORY GROWN DIAMOND

MARQUISE BRILLIANT

11.47 X 5.57 X 3.58 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.28 CARAT

E

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

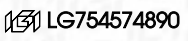
EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



IGI LG754574890

PROPORTIONS

Medium To Slightly Thick (Faceted)

15%

45%

57%

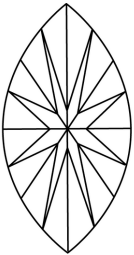
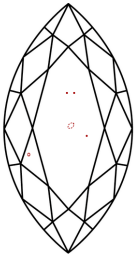
64.3%

Pointed



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



December 8, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG754574890

LABORATORY GROWN DIAMOND

MARQUISE BRILLIANT

11.47 X 5.57 X 3.58 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.28 CARAT

E

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

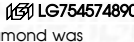
EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



IGI LG754574890



IGI

December 8, 2025

IGI Report No LG754574890

MARQUISE BRILLIANT

11.47 X 5.57 X 3.58 MM

1.28 CARAT

E

VS 1

64.3%

57%

Medium to Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG754574890

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

None

Excellent

Excellent

None

IGI LG754574890

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa